

UC Berkeley

EE C247B - ME C218 Introduction to MEMS Design Spring 2017

Prof. Clark T.-C. Nguyen

Dept. of Electrical Engineering & Computer Sciences
 University of California at Berkeley
 Berkeley, CA 94720

Lecture Module 10: Resonance Frequency

EE C245: Introduction to MEMS Design LecM 10 C. Nguyen 11/4/08 1

UC Berkeley

Lecture Outline

- Reading: Senturia, Chpt. 10: §10.5, Chpt. 19
- Lecture Topics:
 - ↳ Estimating Resonance Frequency
 - ↳ Lumped Mass-Spring Approximation
 - ↳ ADXL-50 Resonance Frequency
 - ↳ Distributed Mass & Stiffness
 - ↳ Folded-Beam Resonator

EE C245: Introduction to MEMS Design LecM 10 C. Nguyen 11/4/08 2

UC Berkeley

Estimating Resonance Frequency

EE C245: Introduction to MEMS Design LecM 10 C. Nguyen 11/4/08/28/07 3 3

UC Berkeley

Clamped-Clamped Beam μ Resonator

Resonator Beam
 W_r , L_r , h

Electrode
 v_i

Voltage-to-Force Capacitive Transducer
 V_P

Sinusoidal Excitation
 $v_i = V_i \cos[\omega_o t] \rightarrow f_i = F_i \cos[\omega_o t]$

Sinusoidal Forcing Function

i_o

$Q \sim 10,000$

$\frac{i_o}{v_i}$

ω_0 , ω

- $\omega \neq \omega_o$: small amplitude
- $\omega = \omega_o$: maximum amplitude \rightarrow beam reaches its maximum potential and kinetic energies

EE C245: Introduction to MEMS Design LecM 10 C. Nguyen 11/4/08/28/07 4 4